



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#7613
7/22/02

In re application of : **Confirmation No. 4252**
Yoichi MORI et al. : **Docket No. 2000-1578A**
Serial No. 09/714,220 : **Group Art Unit 1754**
Filed November 17, 2000 : **Examiner Ngoc-Yen M. Nguyen**

METHOD AND APPARATUS FOR
TREATING A WASTE GAS CONTAINING
FLUORINE-CONTAINING COMPOUNDS

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JUL 18 2002
TC 1700

ELECTION OF INVENTION

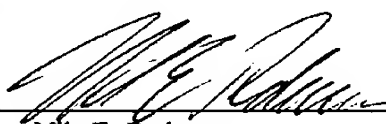
Assistant Commissioner for Patents,
Washington, D.C.

Sir:

In response to the restriction requirement of June 19, 2002, Applicants in the above-referenced U.S. patent application hereby elect the invention of Group II corresponding to claims 5-8. An early and favorable action on the merits is respectfully requested.

Respectfully submitted,

Yoichi MORI et al.

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